

| Search Notes | Application/Control No. | Applicant(s)/Patent under Reexamination |
|--|-------------------------|---|
|  | 10/693,189 | INOUE, TAKASHI |
| | Examiner | Art Unit |
| | Gevell Selby | 2622 |

| INTERFERENCE SEARCHED | | | |
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| Class | Subclass | Date | Examiner |
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